



Magnetic Characterization of Ferromagnetic Metal/Organic Semiconductor Interfaces

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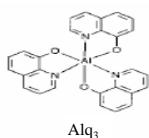
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Abstract

The interface between ferromagnetic metals and organic films plays an important role in the performance of hybrid spintronic devices. We report the magnetic characterization of Co thin films on top of a series of well-known organic semiconductors, namely Alq₃, TPP, Pc and PTCDA. Cobalt thin films were deposited under high vacuum by electron beam evaporation and capped with a 5 nm layer of Al. After each deposition the samples were removed from the vacuum system and hysteresis loops were measured at 300 K with an alternating gradient magnetometer to determine the coercivity (H_c) and saturation magnetization (M_s).

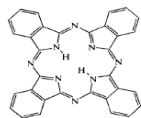
Molecular structures



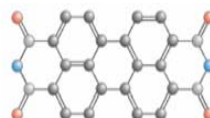
Alq₃



H₂TPP



Pc

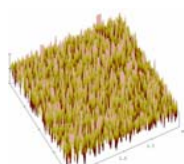
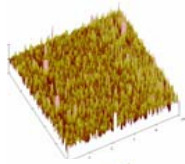
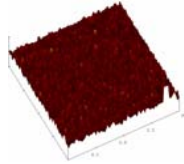


PTCDA

AFM images of 50nm organic films on Si wafers

Alq₃ rms roughness ~1.2nm

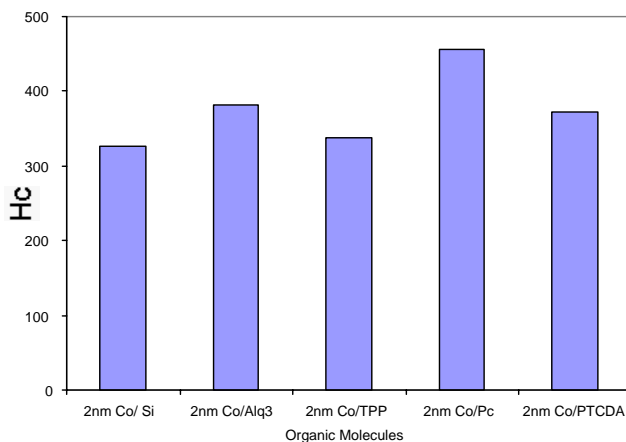
TPP rms roughness ~1.3nm



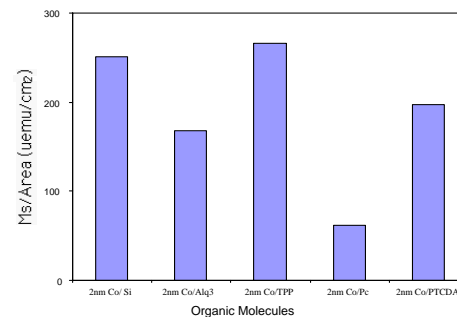
Pc rms roughness ~ 3.3nm

PTCDA rms roughness ~ 2.2nm

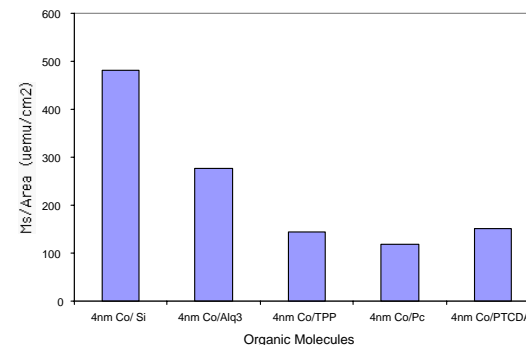
Coercivity of 2nm Co films on different organic molecules



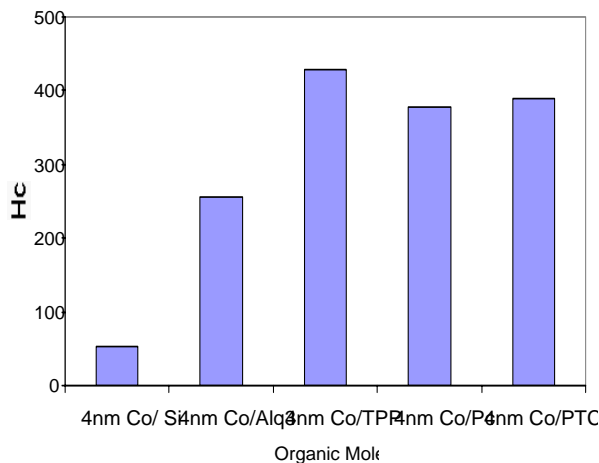
M_s of 2nm Co films on different organic molecules



M_s of 4nm Co film on different organic molecules



Coercivity of 4nm Co films on different organic molecules



Conclusions

-The coercivity of 4 nm Co films on the organic films is much larger than a 4 nm Co film on a Si wafer, which is likely determined by a reduced dimensionality and lower Curie temperature. AFM images support this conclusion, since a rougher organic surface produces the larger coercivity for the Co film.

-The saturation magnetization of the Co films deposited on top of organic magnet is smaller than the value observed on a Si wafer, which indicates the presence of dead magnetic layers. The dead layer is larger on a rough organic film.

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